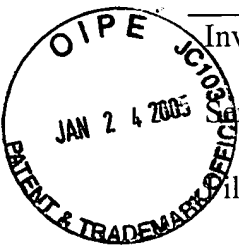


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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Inventor(s): Bian et al.

Serial No.: 10/664,722

Filing Date: 9/17/2003

Title: POLISHING COMPOSITION FOR SEMICONDUCTOR WAFERS

Attorney Docket No.: 03019US

Examiner:

D. Owens

Group Art Unit:

2811

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

STATEMENT UNDER 37 CFR 1.97(e)

Sir:

The undersigned hereby certifies that either:

- (X) Each item of information contained in the Information Disclosure Statement (along with the copy of the European Search Report) was first cited in a communication from its European counterpart application, not more than three months prior to the filing of the statement, or
- () No item of information contained in the Information Disclosure Statement
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Respectfully submitted,

Bian et al.

By

Blake T. Biederman
Attorney for Applicant(s)
Reg. No.: 34,124

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Application Number	10/664,722
Filing Date	9/17/2003
First Named Inventor	Bian et al.
Art Unit	2811
Examiner Name	D. Owens
Attorney Docket Number	03019US

U.S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

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